

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the application of: Shi *et al.*
Application No.: 10/666,671
Filed: 09/17/2003
For: Methods and Apparatus of Etch Process
Control in Fabrications of Microstructures

Docket: TI-62961
Examiner: Vinh, Lan
Art Unit: 1792
Conf. No.: 8251

COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Mail Stop ISSUE FEE
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

CERTIFICATE OF MAILING OR TRANSMISSION

I hereby certify that the above correspondence is being filed electronically with the U.S. Patent and Trademark Office on the date indicated below.

/Sue Short/ 11/30/2009
Sue Short Date

Dear Madam:

In response to the Notice of Allowance and Fee(s) Due mailed September 1, 2009, Applicants submit the following comments:

REMARKS

The Applicants agree with the Examiner's conclusions of patentability, without necessarily agreeing with or acquiescing in the Examiner's reasoning or comments. The Applicant submits that the claims of the above-identified application are allowable because the prior art fails to anticipate or render obvious the invention as claimed.

Respectfully submitted,

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